Temperature-dependence of a GaN-based HEMT monolithic X-band low noise amplifier

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Abstract
The temperature-dependent performance of a fully monolithic AIGaN/GaN HEMT-based X-band low noise amplifier is reported. The circuit demonstrated a noise figure of 3.5 dB, gain of 7.5 dB, input return loss of -7.5 dB, and output return loss of -15 dB at 8.5 GHz at room temperature. The noise figure at 9.5 GHz increased from 2.5 dB at 43°C to 5.0 dB at 150°C.

Keywords
GaN, gallium nitride, SiC, wide bandgap, HEMT, low noise, amplifier, MMIC

INTRODUCTION
The outstanding properties of the Group III-nitride semiconductors (InN, GaN, AlN) such as chemical inertness, wide bandgap, high electron mobility, and high breakdown field have made possible heterostructure devices with high speed, low noise, and very high power performance suitable for harsh environment applications (see for example [3], [4], [7]). Most research in GaN-based transistors has focused on the high power performance of these devices, and as a result, the only AlGaN/GaN HEMT-based low noise amplifier (LNA) reported until very recently was a hybrid circuit [6]. Very recently a few monolithic LNAs have been reported which operated below X-band or which employed sub-quarter-micron gate-length devices or both [1], [2], [8]. This work reports on the temperature-dependent performance of a monolithic microwave integrated circuit (MMIC): an AlGaN/GaN high electron mobility transistor (HEMT)-based low noise amplifier operating at X-band and employing a reliable 0.25-µm gate-length technology. The results demonstrate the potential for the integration of robust low noise amplifiers with ultra-high performance power amplifiers in a single technology for next-generation military and communication systems.

DEVICE AND FABRICATION
A photograph of the GaN-based MMIC LNA is shown in Figure 1. As indicated by Figure 1, the circuit is a single-stage design employing a single 2 × 75 µm GaN-based HEMT. The circuit was fabricated on an epilayer grown by MOCVD on a semi-insulating 4H-SiC substrate. The epilayer consists of a buffer, 2-µm undoped GaN, a 3-nm undoped Al0.32Ga0.68N spacer, a 10-nm Si-doped (≈1 × 1019 cm⁻³) Al0.25Ga0.75N charge supply layer, and a 10-nm undoped Al0.25Ga0.75N barrier layer. The average sheet resistance of the sample was 453 Ω/square. The first step for device fabrication was mesa-isolation using Cl₂/Ar plasma in an inductively-coupled-plasma reactive ion etch (ICP-RIE) system. Ohmic contacts were formed by rapid thermal annealing of evaporated Ti/Au/Mo/Au at 850 °C for 30 s [5]. The 0.25-µm gate-length T-shaped gates (Ni/Au) were defined using electron-beam lithography. The transistors have a source-drain spacing of 2.5 µm and were passivated with 200 nm thick silicon nitride.

The integrated circuit fabrication process consisted of the following steps: mesa isolation, ohmic metal, Schottky gates via e-beam lithography, overlay metal, silicon nitride deposition and etch; nichrome resistor; a 1-µm-thick evaporated gold level; and airbridge. The process incorporates steps which allow the realization of the passive elements required for a complete coplanar waveguide-style MMIC process: low-loss transmission lines, metal-insulator-metal (MIM) capacitors, spiral inductors, and thin-film resistors. Because the LNA has relaxed requirements with respect to thermal impedance and source ground inductance compared to a high power amplifier, this initial LNA MMIC was designed using CPW-style transmission lines and passive elements so that backside processing was not required.

Figure 1. Photograph of the X-band GaN-based LNA MMIC.
DEVICE CHARACTERISTICS

A typical 0.25 μm x 150 μm AlGaN/GaN HEMT has a maximum drain current density of 1.0 A/mm and a peak DC extrinsic transconductance of 170 mS/mm. The threshold voltage is -6.8 V, where the threshold voltage was determined by extrapolating the drain current to zero from the maximum transconductance point.

The small signal and noise performance of a typical 25 μm x 150 μm AlGaN/GaN HEMT at 25 °C are shown in Figure 2. Small signal characteristics were measured using an Agilent 8510B network analyzer. Figure 2(a) shows the short-circuit current gain (I_{21}) and the maximum stable gain/maximum available gain (MSG/MAG) at the device's peak-jc bias point of 13 V drain-source voltage, -6.0 V gate-source voltage and 34.6 mA drain current. The fr of the device is 24.5 GHz. The maximum frequency of oscillation f_{max} is 48 GHz and is determined by extrapolating the maximum available gain (MAG) at -20 dB/decade.

A Maury/ATN NPS noise parameter measurement system along with an Agilent 8970B noise figure meter and 8971C noise figure test set was used to measure device noise parameters from 2 to 20 GHz. Figure 2(b) shows the device's minimum noise figure and associated gain at 25 °C at the device's minimum noise figure bias of 10 V drain-source voltage, -6.7 V gate-source voltage and 10 mA drain current. The minimum noise figure at 10 GHz is seen to be 1.6 dB with an associated gain of 10.6 dB.

CIRCUIT PERFORMANCE

The single-stage LNA employs spiral inductors between the HEMT's source and ground to provide series inductive feedback to bring the optimum noise match f_{opt} closer to f_{r*} to achieve acceptable input return loss while at the same time matching for the optimum noise performance. The output matching network was designed for optimum small signal gain. Bias is applied through the RF input and output probe pads, and bypass capacitors provide AC grounds for the shunt inductors in the input and output matching networks.

Figure 3 shows the small signal and noise performance of the LNA from -43 °C to +200 °C. At -43 °C, the noise figure reached a minimum of 2.5 dB at 9.5 GHz, and at 150 °C the noise figure at 9.5 GHz was 5.0 dB. At 25 °C the monolithic microwave integrated circuit (MMIC) demonstrated a noise figure of 3.5 dB, gain of 7.5 dB, input return loss of -7.5 dB, and output return loss of -15 dB at 8.5 GHz. The rate of change in gain and noise figure with temperature is fairly constant across the frequency band up to 100 °C while at 150 °C the gain and noise figure are degraded non-uniformly across frequency. While encouraging, this suggests that the excellent high temperature (~500 °C) operation expected from GaN-based technology has not been fully realized.

CONCLUSION

The temperature-dependent performance of a fully monolithic AlGaN/GaN-based LNA has been presented. Combined with the very high microwave power performance previously demonstrated by AlGaN/GaN-based HEMT's, these results demonstrate the potential for the integration of a robust low noise amplifier with an ultra-high performance LNA.
power amplifier in a single GaN-based technology for next-generation military and communication systems.

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